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(71) Applicant: **NOVA SOLUTIONS, INC.** [US/US]; 421
West Industrial Avenue, Effingham, IL 62401 (US).

(72) Inventors: **SCHAIRBAUM, Edwrad, C.**; 3221 Suffolk
Court W., Suite 102, Fort Worth, TX 76133 (US). **LECH-**
MAN, John, N.; 9 Cardinal Lane, Effingham, IL 62401
(US).

(74) Agents: **HIERL, Michael, A.** et al.; Olson & Hierl, Ltd.,
20 North Wacker Drive, 36th floor, Chicago, IL 60606
(US).

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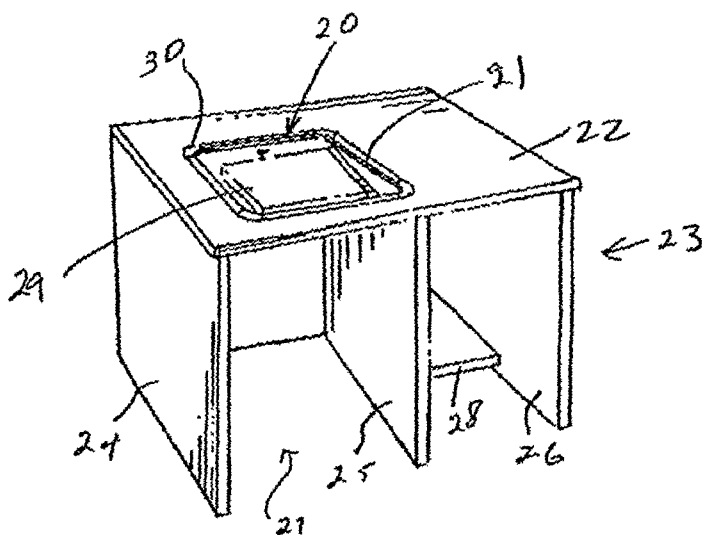
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(54) Title: **FLAT MONITOR SUPPORT TRAY FOR A PLATFORM APERTURE**



(57) Abstract: A flat monitor support apparatus (20) for association with an aperture (21) in a working platform (21). The support apparatus (20) includes an aperture frame (30) that extends about perimeter portions of the aperture, a flat monitor support tray positioned within the aperture frame (30), and support elements for supporting the flat monitor support tray by the aperture frame while the aperture frame is associated with the platform aperture. The aperture frame, the flat monitor support tray, and the support elements co-act to support a flat monitor.



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